



94/STW
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Mitsutoshi MIYASAKA

Group Art Unit: 2815

Application No.: 09/885,027

Examiner: J. Jackson

Filed: June 21, 2001

Docket No.: 036654.04

For: FABRICATION METHOD FOR A THIN FILM SEMICONDUCTOR DEVICE, THE THIN FILM SEMICONDUCTOR DEVICE ITSELF, LIQUID CRYSTAL DISPLAY, AND ELECTRONIC DEVICE

SUBMISSION OF REFERENCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The Issue Fee was paid on January 11, 2005. It is respectfully requested that the attached reference be placed in the Patent Office files. The reference was cited in a Communication from the Japanese Patent Office subsequent to the Issue Fee being paid regarding the above-identified application.

- ☒ 1. A computer-generated English language translation of the attached Japanese reference was unavailable from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]). Therefore, only an English language Abstract is attached.

Respectfully submitted,

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Date: January 18, 2005

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